



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Appln. Of:

TANABE et al.

Serial No.:

09/612,551

Filed:

July 7, 2000

For:

SEMICONDUCTOR THIN FILM FORMING SYSTEM

Group:

1725

Examiner:

GEOFFREY S. EVANS

DOCKET: NEC WNZ-2212

MAIL STOP AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## **AMENDMENT H**

Dear Sir:

This Amendment in being filed in response to the Official Action mailed June 17, 2004.

Please amend the Application as follows:

Amendments to the Claims begin on page 2 of this Amendment.

Remarks/Arguments begin on page 8 of this Amendment.

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